

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Yasuo FUKUDA et al.
Appl. No. : Not yet assigned
Filed : Concurrently herewith
For : EPITAXIAL WAFER AND METHOD FOR PRODUCING SAME

Group Art Unit : Not yet assigned
Examiner : Not yet assigned
Confirmation No. : Not yet assigned

AUTHORIZATION TO CHARGE DEPOSIT ACCOUNT

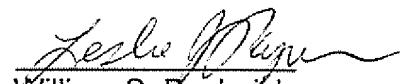
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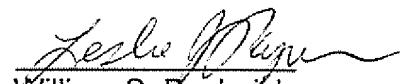
Sir :

The undersigned hereby authorizes the U.S. Patent and Trademark Office to charge any fees necessary to maintain the pendency of the above-identified application, including any basic filing fees, application size fees, search fees, examination fees, extension of time fees, and claim fees, to Deposit Account No. 19-0089.

Should the Examiner have any questions, the Examiner is invited to contact the undersigned at the below-listed telephone number.

Respectfully Submitted,
Yasuo FUKUDA et al.


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June 7, 2006
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